

Application No.	Applicant(s)	
10/722,094	AHN ET AL.	
Examiner	Art Unit	
Paul D. Kim	3729	

SEARCHED				
Class	Subclass	Date	Examiner	
29	602.1 604 605 606	12/21/2004	РК	
156	89.11 89.1			
	229			
257	531			
336	176 200			
	229			
438	238 381	/		
	788 792	, W		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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	ext Search achment	8/7/2007	РК	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Reviewed Parent applications 09/261,595 10/280,180	12/21/2004	PK	
Text Search EAST/NPL (IEEE)	12/21/2004	PK	
Updated Text Search EAST	1/19/2005	PK	
Updated Text Search EAST	6/27/2005	РК	
Updated Text Search EAST	1/12/2006	РК	
Updated Text Search EAST	4/18/2006	PK	
Updated Text Search EAST	12/7/2006	PK	
Updated Text Search EAST/PGPub	8/7/2007	PK	